

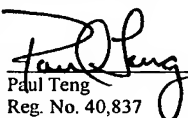
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Dkt. 2271/71521



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of : Takuro SEKIYA  
Serial No. : 10/758,398  
Date Filed : January 15, 2004  
For : SOLUTION JET TYPE FABRICATION APPARATUS, METHOD,  
SOLUTION CONTAINING FINE PARTICLES, WIRING PATTERN  
SUBSTRATE, DEVICE SUBSTRATE

I hereby certify that this correspondence is being transmitted by facsimile transmission this date and is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
 Paul Teng Reg. No. 40,837	Date <u>August 23, 2004</u>

1185 Avenue of the Americas  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to the applicant's duty of disclosure, the information listed in the attached form PTO-1449 is brought to the attention of the Examiner.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

According to the August 5, 2003 OG Notice published by the Patent and Trademark Office, the Office has waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each cited U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international application that have entered the national

stage under 35 U.S.C. §371 after June 30, 2003.

Accordingly, copies are submitted herewith for only references listed on the annexed Form PTO-1449 that are not a U.S. patent or U.S. patent application publication.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that the items are prior art. The items listed are submitted in good faith, but are not intended to substitute for Examiner's search. It is hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

A first Office Action has not been received in connection with the subject application. Accordingly, pursuant to 37 C.F.R. §1.97(b)(3), applicant believes that the present Information Disclosure Statement is timely filed and no fee or certification is due or required.

Alternatively, in the event that a first Office Action has been mailed but has not yet been received by applicant or connected with the application file in the undersigned attorney's office, applicant hereby request, pursuant to 37 C.F.R. §1.97(c)(2), consideration of this Information Disclosure Statement, and authorization is hereby given to charge to Deposit Account No. 03-3125 ONE HUNDRED AND EIGHTY DOLLARS (\$180.00), which is the amount of the fee under 37 C.F.R. §1.17(p) for filing an Information Disclosure Statement pursuant to 37 C.F.R. §1.97(c)(2).

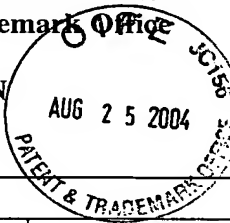
No fee is deemed necessary in connection with the filing of this Information Disclosure Statement. However, if any fee is required, authorization is hereby given to charge the amount of such fee to Deposit Account No. 03-3125.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Paul Teng", is written over a horizontal line.

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Attorney for Applicants  
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<b>Form PTO-1449</b>		<b>U.S. Department of Commerce Patent and Trademark Office</b>		Atty. Docket No. <b>2271/71521</b>	Serial No. <b>10/758,398</b>
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Applicants: <b>Takuro SEKIYA</b>	
				Filing Date: <b>January 15, 2004</b>	Group Art Unit:



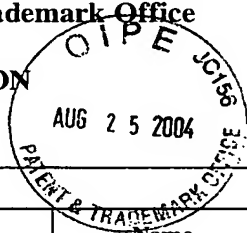
U.S. PATENT DOCUMENTS											
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate					
	3 2 9 8 0 3 0	1/10/67	Lewis et al.								
	3 5 9 6 2 7 5	7/27/71	Sweet								
	3 6 8 3 2 1 2	8/8/72	Zoltan								
	3 7 4 7 1 2 0	7/17/73	Semme								
	3 9 4 6 3 9 8	3/23/76	Kyser et al.								
	4 5 0 4 8 4 4	3/12/85	Ebi et al.								
	4 5 1 0 5 0 9	4/9/85	Horike et al.								
	4 6 3 1 5 5 3	12/23/86	Sekiya								
	4 9 9 0 9 3 9	2/5/91	Sekiya et al.								
	5 1 7 2 1 3 9	12/15/92	Sekiya et al.								
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	5 8 7 7 7 8 6	3/2/99	Sekiya et al.								

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					Yes	No	
JP 54-51837	4/24/1979	Japan			Abstract		
JP 2000-126681	5/9/2000	Japan			Abstract		
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JP 2002-134878	5/10/2002	Japan			Abstract		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	"Cadmium Sulfide of Small Dimensions Produced in Inverted Micelles", Lianos, P. et al., Chemical Physics Letters, Vol. 125 No. 3, 1986.
	"Epitaxial Growth of Highly Luminescent CdSe/CdS Core/Shell Nanocrystals with Photostability and Electronic Accessibility", Peng, X. et al., J. Am. Chem. Soc., 119, 1997.
EXAMINER	DATE CONSIDERED

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>Form PTO-1449</b>		<b>U.S. Department of Commerce Patent and Trademark Office</b>		Atty. Docket No. <b>2271/71521</b>		Serial No. <b>10/758,398</b>	
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Applicants: <b>Takuro SEKIYA</b>			
				Filing Date: <b>January 15, 2004</b>		Group Art Unit:	



U.S. PATENT DOCUMENTS									
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate		
		6 0 3 9 4 2 5	3/21/00	Sekiya et al.					
		6 1 9 3 3 48 B1	2/27/01	Sekiya et al.					
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		6 5 6 8 7 78 B1	5/27/03	Sekiya et al.					
		6 5 9 8 9 59 B2	7/29/03	Sekiya					

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

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